



IUMRS-ICEM 2018

AUGUST 19(SUN.) - 24(FRI.), 2018 / DAEJEON, KOREA

Session Title	3D Device Printing III	Session Code	Mo-H3
Date and Time	2018-08-20 / 16:00 - 18:00		
Place	Room H		
Session Chair	TBA		

Mo-H3-1

16:00 - 16:30

[Invited] High-Resolution 3D Printing for Wearable Electronics

Jang-Ung Park
UNIST, Korea

Mo-H3-2

16:30 - 17:00

[Invited] Scratch to Sensitize; Scratch Induced Sensitivity Enhancement in Thin-Film Types of Sensors

Geonhee Lee^{1,2}, Min Choi^{1,3}, Soo Sang Chae¹, Duwon Jeong¹, Yunho Kim¹, Hyunju Chang¹, and Jeong-O Lee⁴

¹KRICT, Korea, ²Sungkyunkwan Univ., Korea, ³UNIST, Korea, ⁴KRICT, Korea

Mo-H3-3

17:00 - 17:30

[Invited] Customized Nanomaterials for Advanced Applications Viz White Light and Thermoelectric

Priyesh More
DIAT, India